



# Influence of the nozzle head geometry on the energy flux of an atmospheric pressure plasma jet

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## Abstract

The influence of different nozzle head geometries and, therefore, the variation of the excitation and relaxation volume on the energy flux from an atmospheric pressure plasma jet to a surface have been investigated. Measurements have been performed by passive calorimetric probes under variation of the gas flow through the nozzle. The results show that the geometry of the nozzle head has a significant impact on the resulting energy flux. The relaxation volume affects the dependence of the energy flux on the gas flow. While there is no significant influence of the working gas flow on the energy flux without a relaxation volume, utilizing a relaxation volume leads to a decrease of the energy flux with increasing working gas flow. Within the analyzed parameter range, the energy flux reveals for both nozzle heads a linear dependency on the applied primary voltage.

**Keywords:** Calorimetry, Plasma arc devices, Nozzle head geometry

## Introduction

Atmospheric pressure plasma treatment has received growing interest in various industrial applications for surface cleaning, activation, functionalization, etching or coating processes during the last decades [1–4]. The processes offer different opportunities and advantages compared to low pressure plasmas, e.g. the lack of maintenance for vacuum equipment or the inline sequential treatment possibilities. The use of atmospheric pressure plasma jets enables the treatment of selected areas without masking. Hence, this technology is very interesting in several applications ranging from automotive industry to medicine [5, 6]. With such a plethora of applications, the interest in understanding the general interaction mechanisms of an atmospheric pressure plasma jet with a surface in order to improve the processes is high. Even as this field of research is not new, many of the correlated phenomena during the treatment processes are not fully understood up to now [7]. Many open questions are closely correlated to the plasma – surface interactions (especially for layer deposition) since they include chemical as well as physical effects which interact with each other and which strongly influence the results of surface treatment. There are several explanations for the

various phenomena, but because there are a large number of possible interactions which may vary due to the different treatment parameters it is difficult to identify the dominant quantities. These effects include configuration of electrodes, excitation frequency and voltage, gas composition and gas flow as well as the geometry and dimension of the system [8]. The correlated different characteristics have to be investigated in more detail to develop a more complete theoretical framework.

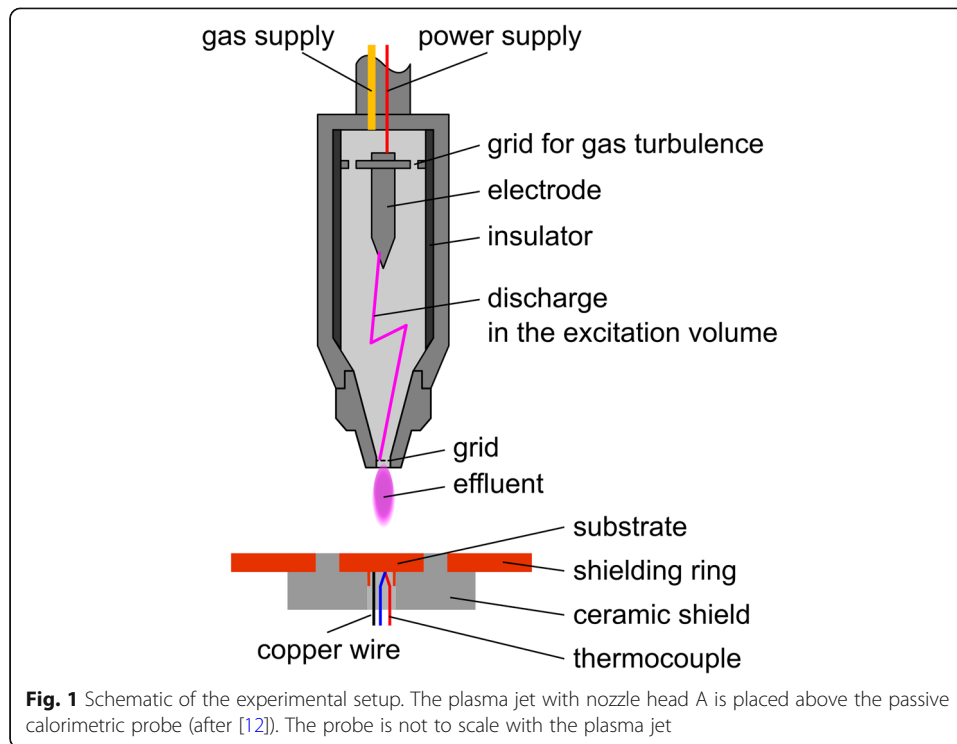
Meanwhile, for a successful surface treatment some effects have a critical impact on whether plasma treatment can be applied successfully to the substrate material. Among these quantities, the energy flux to the substrate surface plays a crucial role. An excessive energy impact cannot only have a significant impact on the fragmentation and deposition conditions for plasma polymer coatings (chemically and in terms of topography) but can change the characteristic surface properties or result in the destruction of the substrate, respectively [9–11]. In order to correlate the plasma and process parameters to the energy flux and to optimize the processes, related experiments have been performed in this work. The experiments were focused on the influences of the working gas flow and excitation voltage for two different nozzle head geometries of the jet. The gas flow and the applied primary voltage reflect two of the most important jet parameters regarding the excitation energy. Additionally, the nozzle heads provide different excitation and relaxation volumes. The excitation volume is the volume in which the discharge is generated. The ensuing relaxation volume is a confined space, in which the effluent is shielded from the surrounding atmosphere. Some energy flux measurements regarding one of the nozzle head shapes are presented in [12] and for a similar situation to the second nozzle head shape but with a different version of the atmospheric pressure plasma jet system in [13]. Apart from different system versions, which make a comparison of the results difficult, these works focused on other parameters, e.g. the distance between nozzle and substrate.

The energy flux is a crucial process parameter [14–16] and can be measured by a passive calorimetric probe [16]. This diagnostic method has already been successfully applied to various plasma sources at low pressure [17–21], e.g. magnetron, ion beam and RF-plasmas [16, 22–24], and also to atmospheric pressure plasmas [25, 26]. The geometries of the probes vary according to the probe type and the investigated plasma source [27]. The probe design used for the present experiments was adapted to the high energy flux and high gas flow emitted by the plasma jet. The design of the probe is presented in [12] and the data analysis used in this study is the one discussed in [28].

## Experimental

For the experimental investigations we used a commercially available pulsed atmospheric pressure plasma generator type FG 5005 with a HTR 11 transformer in connection to a PFW 10 plasma nozzle from the company Plasmatreat GmbH [29]. Figure 1 shows a schematic drawing of the used plasma jet.

The primary voltage was varied between 250 V and 450 V (peak values) resulting in a corresponding primary current of 9 A to 14 A (peak values). The pulse frequency was set to 19 kHz and the duty cycle to 50%. Nitrogen was used as process gas with flow rates in the range of 20 slm to 50 slm adjusted by a mass flow controller by Bronkhorst (F 202 AV). The experimental parameters are summarized in Table 1.

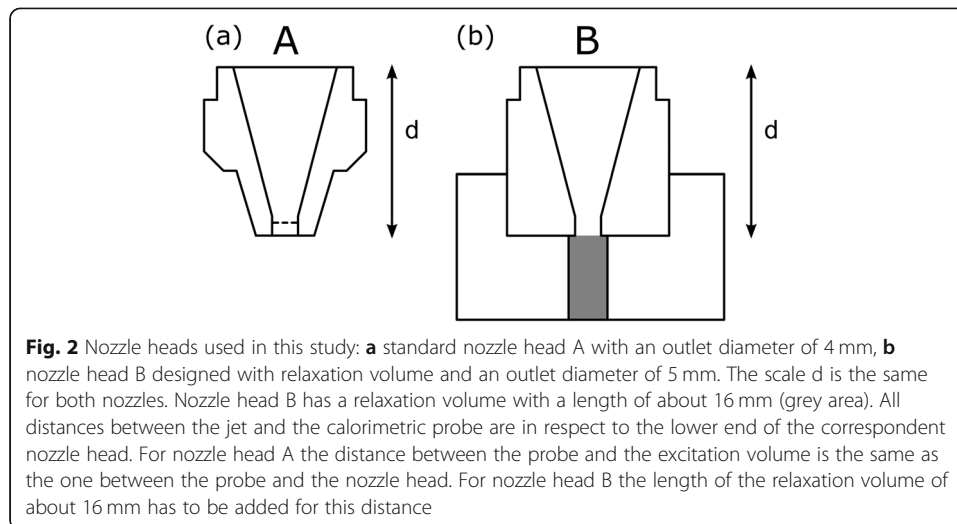


The calorimetric probe used for the energy flux measurements is also shown in Fig. 1. It consists of a 1 mm thick copper plate with a diameter of 5 mm. A K-type thermocouple and a copper wire are hard soldered to the backside of the probe. The copper plate is surrounded by a ceramic shield made of Macor to protect the thermocouple from direct interaction with the plasma effluent. Furthermore, a second copper plate with a diameter of 40 mm surrounds the Macor shielding. This second plate imitates the geometry of a large substrate and influences the gas flow accordingly. The temperature signal was sampled with 100 Hz. Before the jet was moved over the calorimetric probe plasma was ignited for 2 min in a stand-by position to achieve stable discharge conditions. The interaction time between plasma effluent and probe was adapted to the expected energy flux and was in the range of some seconds up to about 40 s. Owing to the different time scales, the calorimetric measurements are integral measurements over many plasma pulses during a treatment cycle.

Two different plasma nozzle head designs, shown in Fig. 2, have been investigated and compared for this study. Nozzle head A made of a Fe-Ni-Cr alloy is consistent with a standardized nozzle head from Plasmatrete for PFW10. The inside is conical and a

**Table 1** Overview of the experimental parameters

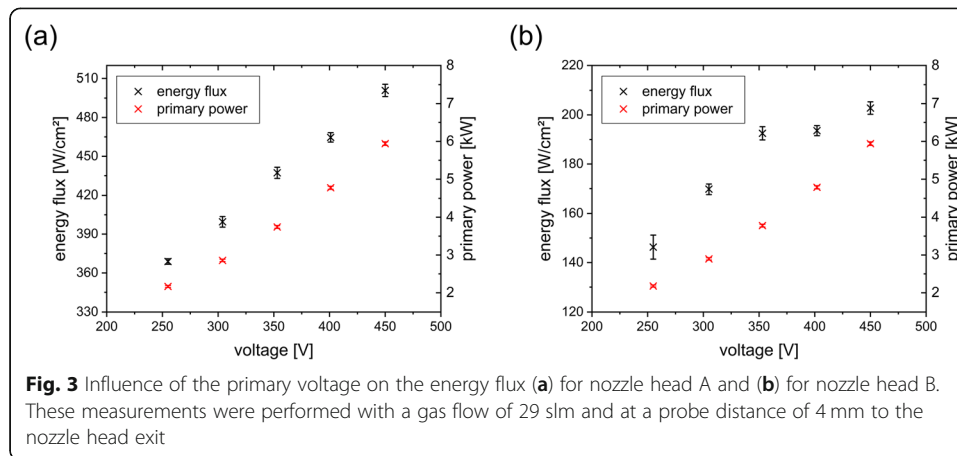
Parameter	Range	Standard setting
Primary voltage	250 V – 450 V	400 V
Process gas (N <sub>2</sub> )	20 slm – 50 slm	29 slm
Pulse frequency	19 kHz	
Duty cycle	50%	
Sample rate	100 Hz	
Distance	4 mm – 16 mm	4 mm



grid is placed near the end of the nozzle exit. The grid limits the expansion of the electrical discharge to the inner volume of the plasma jet resulting in a limited excitation volume. Nozzle head B made of stainless steel was designed for coating applications. In principle, this head has the same inner geometry and the same inner dimensions for the excitation volume as head A, but the grid was omitted and an additional relaxation volume is added directly to the nozzle exit. As the grid no longer limits the discharge length, the effluent can propagate in the adjacent relaxation volume. Hence, the exact excitation and relaxation volumes depend on the discharge length which depends on the discharge parameters, especially, the input power and the gas flow. In general, a distance of 4 mm between the nozzle and the substrate of the calorimetric probe was chosen which is similar to an industrial working distance for plasma polymer coating processes.

## Results and discussion

The results show a linear dependence of the energy flux on the primary voltage and the primary power within the analyzed parameter range for nozzle head A as well as nozzle head B (compare Fig. 3a and b). This is expected, since an increased amount of energy for a constant gas flow results in a higher plasma density and a higher average temperature, leading to an increased energy flux. The results for nozzle head A are in agreement with those from a similar configuration of plasma jet with nozzle [12]. A comparison between the two nozzle heads emphasizes that the energy flux achieved with nozzle head B is remarkably lower than the energy flux with nozzle head A for the same distance of 4 mm between nozzle and probe. Here, the same distance relates to the free path in the surrounding atmosphere between the nozzle head and the probe. For both nozzle heads, the fraction reaching the substrate of the probe originates preferably from the center of the flow where the gas has presumably the highest temperature (ref. [12, 30–32]). The relaxation volume of nozzle head B results in an increased time for collisions and, thereby, extended thermalization of the gas due to the added distance between the excitation volume and the probe. This leads to a smaller temperature gradient and less energy transfer through the center of the flow.

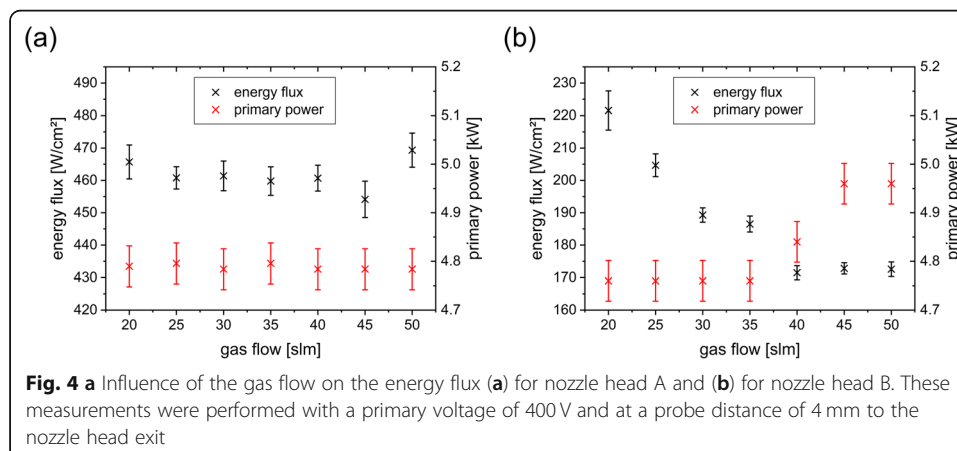


Additionally, energy is dissipated due to plasma wall collisions resulting in even lower energy fluxes.

Apart from the voltage, the influence of the working gas flow was investigated. The results presented in Fig. 4a and b show different effects. The nozzle head A (Fig. 4a) shows no significant influence on the energy flux by the amount of working gas. Conversely, nozzle head B shows a decreasing energy flux with an increasing amount of gas until 40 slm and stays constant above this value (Fig. 4b). This means, that the geometry of the nozzle head influences the dependence on the gas flow. The decreasing energy flux is attributed to the smaller temperature gradient due to the extended thermalization in nozzle head B. Distributing the available energy to a larger amount of gas leads to reduced gas temperatures and smaller energy fluxes.

The amount of gas can also have an effect on the input energy. The more gas flows through the nozzle, the less ionized and reactive molecules are still within the excitation volume during the next pulse. This leads to a less pre-ionized channel between the electrodes inside the nozzle and, therefore, higher powers for the arc-ignition might be needed.

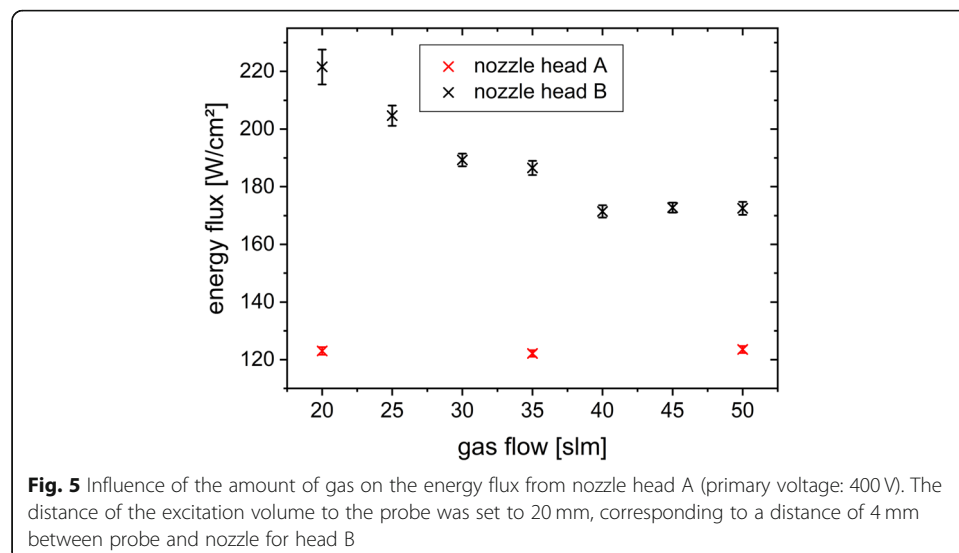
For nozzle head B the primary current, which is determined by the discharge, stays constant at 11.9 A until 35 slm and rises for higher gas flows up to 12.4 A, leading to increased primary powers. This seems to counteract a further decrease of the energy



flux due to the larger amounts of gas, resulting in a constant energy flux. As nozzle head B has no grid at the nozzle exit, the higher gas flow might also blow the discharge effluent further out of the nozzle into the relaxation volume during a discharge pulse. Hence, the excitation volume and the discharge length might be extended, which may lead to a higher power for the following pulse as well.

The relaxation volume in nozzle head A is very small in comparison to B. The energy cannot be distributed so efficiently and is concentrated more to the center of the effluent. The primary current is constant at 11.9 A for all gas flows (Fig. 4a). Further, the higher temperatures of the grid reduce the work function, probably leading to an increased stability of the discharge. The constant energy flux implies that the decreased energy to gas ratio is compensated by the increased amount of gas reaching the substrate of the probe due to the higher gas velocities.

Although, the two nozzle geometries show a similar tendency for the dependence of the energy flux on the primary voltage, they differ significantly in their energy fluxes as function of the gas flow. As shown in a previous paper for nozzle head A with a slightly different system (transformer HTR 12: different windings and design; generator FG5001) [12] the general dependence of the energy flux to the probe depends strongly on the distance to the probe. Using nozzle head B increases the distance between the excitation volume and the calorimetric probe due to the additional relaxation volume significantly. In order to investigate if the distance is the reason for the difference in energy flux levels or if the relaxation volume has an additional influence, we performed further measurements at an equal distance of 20 mm between the excitation volume and the probe. This distance is equivalent to the 4 mm distance between nozzle head B and the probe. The results in Fig. 5 are directly compared to those from nozzle head B already shown in Fig. 4b. The energy flux for nozzle head A is considerably lower compared to nozzle head B. Again, the gas flow does not have a significant impact on the energy flux for nozzle head A. We can assume that the energy flux is at the same level in the excitation volume inside the two different nozzles due to the same geometry. The main difference between the two setups is the subdivision of the distance in between the excitation volume and the probe. For nozzle head A the distance is



characterized by a turbulent flow outside the nozzle with a strong effect of the colliding excited molecules with the neutral molecules of the surrounding atmosphere for 20 mm. This nozzle head seems to form a uniform temperature profile within the flow inside the effluent with decreasing values for higher distances. In comparison, the distance in case of nozzle head B is subdivided in two parts. One part is the relaxation volume with no contact to the outside atmosphere (16 mm), where only the collisions between the species and with the wall can thermalize the energy distribution and lead to losses. The following part is characterized by a turbulent flow of the species outside the nozzle (4 mm). While there are losses to the wall, they are small compared to the losses to the surrounding atmosphere, since the wall heats up over time and, therefore, limits the cooling effect along the distance to the probe. This leads to huge differences in the energy flux to the surface showing that the relaxation volume has an additional effect to the added distance.

As a main result our data show, that not only the distance between the excitation volume and the surface is important for the absolute energy flux, but also the manner in which the space in between the excitation volume and the surface is connected to the outer atmosphere.

## Conclusion

It was demonstrated that the energy flux onto the treated material from the presented atmospheric pressure plasma jet can be modified by the design of the nozzle head, the amount of working gas and the primary voltage. The results clearly indicate that the design of the nozzle head not only has a big influence on the energy flux but also on the dependence of the gas flow on the energy flux. While the amount of working gas has almost no influence for the investigated set of parameters for nozzle head A without any relaxation volume, the energy flux changes significantly using nozzle head B with a relaxation volume. Meanwhile, the influence of the primary voltage is comparable for both nozzle heads. It was also shown, that the energy flux is decreased by the relaxation volume due to losses at the wall and thermalization of the gas compared for an equal distance between the nozzle head and the probe. If, conversely, the distance between the excitation volume and the probe is equal, the relaxation volume leads to higher energy fluxes. The reason is that the losses within this volume are small compared to the losses due to gas expansion and mixture with the surrounding atmosphere. Therefore, such a relaxation volume offers the opportunity to treat a substrate with higher energy fluxes at greater distances. These results are of special interest for the adjustment of the energy in the plasma at certain distances from the excitation volumes in order to control the precursor fragmentation. They are further important for the design of new nozzle heads for thermally sensitive substrates. With our findings it is possible to design nozzle heads with tailored energy fluxes.

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## Authors' contributions

TK and CR collected and interpreted the data and were major contributors in writing the manuscript. TK analyzed the data. MF, JI and HK revised the manuscript. All authors read and approved the final manuscript.

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### Availability of data and materials

The datasets used and/or analyzed during the current study are available from the corresponding author on request.

### Competing interests

The authors declare that they have no competing interests.

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